

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: **Masashi Goto et al.**

Title: **DIELECTRIC FILM, ITS FORMATION METHOD,  
SEMICONDUCTOR DEVICE USING THE DIELECTRIC  
FILM AND ITS PRODUCTION METHOD**

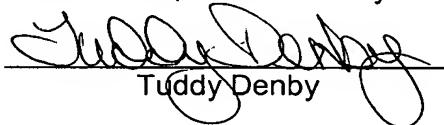
Application No.: **TBD**

Filing Date: **2 December, 2003**

Attorney Docket No.: **2204-11-3**

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited in the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR, Section 1.10 to: Mail Stop Patent Application, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 2<sup>nd</sup> day of December 2003.



**Tuddy Denby**

**PRELIMINARY AMENDMENT**

**TO THE COMMISSIONER FOR PATENTS:  
P.O. Box 1450  
Alexandria, VA 22313-1450**

The Applicants request preliminary amendment of the above referenced patent application as follows.

**AMENDMENT**

**Amendments to the Specification** begin on page 2 of this paper.